

Attorney Docket no: 0553-0193.01

N THE UNITED STATES PATENT AND TRADEMARK OFFICE

in re Application of:		\
		I hereby certify that this correspondence is being
Takayama et al.		deposited with the United States Postal Service as first class mail in an envelope addressed to:
Serial No.:	10/672,521	Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450 on
Filed:	September 26, 2003	Occombe 2, 2005 (Date of Deposit)
Provid	Material, Semiconductor Device ed With A Wiring Using The Wiring al And Method of Manufacturing of	Shannon Wallace Name of applicant, assignee, or Registered Rep. Signature Date
Examiner:	Ha T. Nguyen	,)

Commissioner for Patents P. O. Box 1450 Alexandria, VA 22313-1450

2812

Art Unit:

AMENDMENT D (AFTER FINAL)

In response to the Final Rejection of August 9, 2005 and the Advisory Action of November 22, 2005, a RCE and one month extension of time being submitted herewith, please amend the above-identified application as follows: